Series V60

PROTECTION GATE VALVE

PRESYS
PREMIUM SYSTEM



Application

_Etch, CVD(MO, PE, HDP, LP) Implant, Sputtering
_Nanotechnology process with high particulate levels
_Thin film photovoltaic panels

Features

_Protects process environment from back-streaming powder in the event of dry pump failure
_Reduces expensive down time in powder producing process
_Fast pneumatic actuation-closes in 〈 0.3seconds(Normal 0.7seconds)
_Long cycle life under adverse process conditions

Options

_Custom sizes available
_1, 2, 3 or 4channel options

www.presys.kr

PREMIUM SYSTEM PRESYS

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